IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Jeffery S. Hess

Examiner:

Unknown

Serial No.:

Unknown (Parent Serial No. XX/XXX,XXX)

Art Unit:

Unknown

(Parent Docket No. 10010488-1)

Filed:

Herewith (Parent Filing Date 01/31/2002)

Docket No.:

10010488-2

Title:

SUBSTRATE AND METHOD OF FORMING SUBSTRATE FOR FLUID

EJECTION DEVICE

PRELIMINARY AMENDMENT

BOX PATENT APPLICATION Commissioner for Patents Washington, D.C. 20231

Sir/Madam:

This Preliminary Amendment modifies the Continuation Application filed herewith. Prior to examination of the Continuation Application, please amend as follows:

IN THE SPECIFICATION

Following the Title, please insert the following paragraph:

This application is a Continuation of U.S. Patent Application Serial No. XX/XXX,XXX, entitled "SUBSTRATE AND METHOD OF FORMING SUBSTRATE FOR FLUID EJECTION DEVICE", having Attorney Docket No. 10010488-1, filed on January 31, 2002, assigned to the assignee of the present invention, and incorporated herein by reference.

Please amend the Summary of the Invention as follows:

delete page 2, lines 6-15 (all inclusive) and insert the following:

One aspect of the present invention provides a method of forming an opening through a substrate. The method includes etching a first portion of the opening into the substrate from a first side, etching a plurality of second portions of the opening into the substrate from a second side opposite the first side, continued etching of at least one of the first portion and the plurality of

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